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CONFIRMATION NO. FILING DATE FIRST NAMED INVENTOR ATTORNEY DOCKET NO. APPLICATION NO. 4228 B-3964 618029-8 09/768,904 01/24/2001 Lap-Wai Chow EXAMINER 04/19/2004 NGUYEN, JOSEPH H Victor Repkin, Esq. c/o LADAS & PARRY ART UNIT PAPER NUMBER **Suite 2100** 5670 Wilshire Boulevard 2815 Los Angeles, CA 90036-5679 DATE MAILED: 04/19/2004

Please find below and/or attached an Office communication concerning this application or proceeding.

	Application No.	Applicant(s)	
_	09/768,904	CHOW ET AL.	W
Office Action Summary	Examiner	Art Unit	
	Joseph Nguyen	2815	
The MAILING DATE of this commu	nication appears on the cover s	heet with the correspondence ac	ddress
Period for Reply			
A SHORTENED STATUTORY PERIOD THE MAILING DATE OF THIS COMMUITE OF THIS COMMUITE. Extensions of time may be available under the provision after SIX (6) MONTHS from the mailing date of this contribute. If the period for reply specified above is less than thirty of NO period for reply is specified above, the maximum Failure to reply within the set or extended period for reply received by the Office later than three months earned patent term adjustment. See 37 CFR 1.704(b).	NICATION. ns of 37 CFR 1.136(a). In no event, howeve nmunication. (30) days, a reply within the statutory minim statutory period will apply and will expire SIX bly will, by statute, cause the application to be after the mailing date of this communication.	r, may a reply be timely filed um of thirty (30) days will be considered time ((6) MONTHS from the mailing date of this of ecome ABANDONED (35 U.S.C. § 133).	aly. communication.
Status			
1) Responsive to communication(s) f	iled on <u>16 January 2004</u> .		
2a) ☐ This action is FINAL.	2b) This action is non-final.		
3) Since this application is in condition for allowance except for formal matters, prosecution as to the merits is closed in accordance with the practice under <i>Ex parte Quayle</i> , 1935 C.D. 11, 453 O.G. 213.			
Disposition of Claims			
4) ⊠ Claim(s) <u>1-20,23 and 24</u> is/are per 4a) Of the above claim(s) is 5) ⊠ Claim(s) <u>1-8,17 and 18</u> is/are allow 6) ⊠ Claim(s) <u>9-16,19 and 20</u> is/are rejected 7) ⊠ Claim(s) <u>23 and 24</u> is/are objected 8) ☐ Claim(s) are subject to rest	/are withdrawn from considerat ved. ected. I to.		
Application Papers			
9) The specification is objected to by 10) The drawing(s) filed on 05/07/2003 Applicant may not request that any observation Replacement drawing sheet(s) included 11) The oath or declaration is objected.	f is/are: a) \square accepted or b) \square bjection to the drawing(s) be held in ing the correction is required if the	n abeyance. See 37 CFR 1.85(a). drawing(s) is objected to. See 37 (CFR 1.121(d). PTO-152.
Priority under 35 U.S.C. § 119			
2. Certified copies of the prior3. Copies of the certified copie	: ity documents have been receivity documents have been receives of the priority documents have titional Bureau (PCT Rule 17.2(a	ved. ved in Application No ve been received in this Nationa a)).	al Stage
Attachment(s) 1) Notice of References Cited (PTO-892) 2) Notice of Draftsperson's Patent Drawing Review 3) Information Disclosure Statement(s) (PTO-1448)	v (PTO-948) F 9 or PTO/SB/08) 5) 🔲 N	nterview Summary (PTO-413) Paper No(s)/Mail Date Notice of Informal Patent Application (P	TO-152)
Paper No(s)/Mail Date	6) 📙 0	Other:	

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DETAILED ACTION

Claim Rejections - 35 USC § 102

The following is a quotation of the appropriate paragraphs of 35 U.S.C. 102 that form the basis for the rejections under this section made in this Office action:

A person shall be entitled to a patent unless -

(e) the invention was described in (1) an application for patent, published under section 122(b), by another filed in the United States before the invention by the applicant for patent or (2) a patent granted on an application for patent by another filed in the United States before the invention by the applicant for patent, except that an international application filed under the treaty defined in section 351(a) shall have the effects for purposes of this subsection of an application filed in the United States only if the international application designated the United States and was published under Article 21(2) of such treaty in the English language.

Claims 9-16, 19-20 are rejected under 35 U.S.C. 102(e) as being anticipated by Lee et al.

Regarding claim 9, Lee et al discloses on figure 8 a semiconductor device adapted to prevent and/or thwart reverse engineering comprising field oxide layer 33 disposed on a semiconductor substrate 31; a metal plug contact 42 disposed outside a contact region 38b and above said field oxide layer, wherein said metal plug contact is electrically isolated from said contact region; and a metal 43 connected to said metal plug contact 42.

Regarding claim 10, Lee et al discloses on figure 8 said semi-conducting device comprises integrated circuit.

Regarding claim 11, Lee et al discloses on figure 8 said filed oxide layer 33 further comprises silicon oxide.

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Regarding claim 12, Lee et al discloses on figure 8 said integrated circuits further comprise complementary metal oxide semiconductor integrated circuits and bipolar silicon based integrated circuits.

Regarding claim 13, Lee et al discloses on figure 8 a method for preventing and/or thwarting reverse engineering comprising steps of providing a field oxide layer 33 disposed on a semiconductor substrate 31; providing a metal plug contact 42 disposed outside a contact region 38 and above said field oxide layer 33, wherein said metal plug metal is electrically isolated from said contact region; and connecting a metal 43 to said metal plug contact 42.

Regarding claim 14, Lee et al discloses on figure 8 said semi-conducting device comprises integrated circuit.

Regarding claim 15, Lee et al discloses on figure 8 said filed oxide layer 33 further comprises silicon oxide.

Regarding claim 16, Lee et al discloses on figure 8 said integrated circuits further comprise complementary metal oxide semiconductor integrated circuits.

Regarding claim 19, Lee et al discloses on figure 8 said filed oxide layer 33 has an uppermost side, said metal plug contact 42 being deposed on said uppermost side of said field oxide layer.

Regarding claim 20, Lee et al discloses on figure 8 said filed oxide layer 33 has an uppermost side, said metal plug contact 42 being deposed on said uppermost side of said field oxide layer.

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Allowable Subject Matter

Claims 23-24 are objected to as being dependent upon a rejected base claim, but would be allowable if rewritten in independent form including all of the limitations of the base claim and any intervening claims.

Claims 1-8, 17-18 are allowed.

Response to Arguments

Applicant's arguments with respect to claims 9-16, 19-20 have been considered but are most in view of the new ground(s) of rejection.

Conclusion

Any inquiry concerning this communication or earlier communications from the examiner should be directed to Joseph Nguyen whose telephone number is (571) 272-1734. The examiner can normally be reached on Monday-Friday, 7:30 am- 4:30 pm

If attempts to reach the examiner by telephone are unsuccessful, the examiner's supervisor, Tom Thomas can be reached on (571) 272-1664. The fax phone number for the organization where this application or proceeding is assigned is (703) 872-9306 for regular communications. Any inquiry of a general nature or relating to the status of this application or proceeding should be directed to the receptionist whose telephone number is (703) 308-0956.

JN April 7, 2004

